

Application Serial No. 10/667,006  
Response C dtd. 11/05/07  
Response to Office Action of 8/9/07

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael E. Mack  
Application Serial No.: 10/667,006  
Filed: September 19, 2003  
Title: SYSTEM FOR AND METHOD OF GAS CLUSTER ION BEAM PROCESSING  
Attorney Docket: 11460-127

Confirm. No.: 9136  
Group Art Unit: 1753  
Examiner: McDonald, Rodney Glenn  
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To: Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE C**

Dear Sir:

This filing is in response to the Official Action dated August 9, 2007 in the above-identified patent application, the response time for which Official Action was set at three months.

**Amendments to the claims begin on page 2 of this paper.**

**Remarks begin on page 10 of this paper.**